

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Kaoru Koike, et al. **ATTY DOCKET NO.:** 9792909-5759
SERIAL NO.: not yet assigned **GROUP ART UNIT:** not yet assigned
DATE FILED: November 13, 2003 **EXAMINER:** not yet assigned
INVENTION: "MASK-MAKING MEMBER AND ITS PRODUCTION METHOD,
MASK AND ITS MAKING METHOD, EXPOSURE PROCESS,
AND FABRICATION METHOD OF SEMICONDUCTOR DEVICE"

which is a Divisional of the following copending U.S. Application:

APPLICANT: Kaoru Koike, et al. **ATTY DOCKET NO.:** 9792909-5344
SERIAL NO.: 10/080,104 **GROUP ART UNIT:** 2826
DATE FILED: February 21, 2002 **EXAMINER:** F. Erdem
INVENTION: "MASK-MAKING MEMBER AND ITS PRODUCTION METHOD,
MASK AND ITS MAKING METHOD, EXPOSURE PROCESS,
AND FABRICATION METHOD OF SEMICONDUCTOR DEVICE"

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Please amend the accompanying application as follows: